

L Number	Hits	Search Text	DB	Time stamp
1	19	block adj mold\$3 and semiconductor and clean\$3	USPAT	2003/01/06 10:50
2	0	mold\$3 and semiconductor near4 clean\$3 same rie same roughen\$	USPAT	2003/01/06 12:57
3	1	mold\$3 and semiconductor near4 clean\$3 same plasma same roughen\$	USPAT	2003/01/06 11:05
4	0	mold\$3 and semiconductor same substrate near4 clean\$3 same plasma same roughen\$	USPAT	2003/01/06 11:29
5	27	mold\$3 and semiconductor same substrate near4 clean\$3 same plasma	USPAT	2003/01/06 12:49
6	0	"6200121" and fr4	USPAT	2003/01/06 14:15
7	86	mold\$4 same fr4	USPAT	2003/01/06 12:51
8	0	mold\$3 and fr4 same semiconductor near4 clean\$3	USPAT	2003/01/06 13:01
9	69	mold\$3 and fr4 same semiconductor	USPAT	2003/01/06 13:01
10	1	"6200121" and clean\$	USPAT	2003/01/06 14:15
11	1	"6200121" and clean\$4	USPAT	2003/01/06 14:50
14	30	multiple same stack\$3 same chips same encapsulat\$4	USPAT	2003/01/06 14:54